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(Attorney Docket No. 98010CONDIV)

First Inventor: Vlasta BRUSIC

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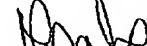
Title: CHEMICAL MECHANICAL  
POLISHING SLURRY USEFUL  
FOR COPPER SUBSTRATES

Examiner: Goudreau, G.

Art Unit: 1763

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RESPONSE TO OFFICE ACTION

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This is a reply to the Office Action issued in the above-captioned U.S. patent  
application on May 31, 2006.

Amendments to the Claims are reflected in the listing of claims beginning on page 2  
of this paper.

Remarks begin on page 4 of this paper.

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